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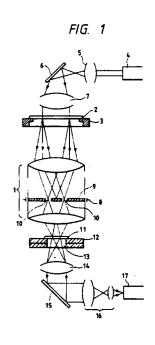
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- (54) Apparatus for evaluating a lens.
- (57) A first reticle (2) is located at an object position of a lens (1) to be evaluated. The first reticle is formed with a first diffraction grating. A stage (3) supports the first reticle. A coherent light source (4) illuminates a whole region of the first diffraction grating. A spatial filter (9) blocks a 0-order component of diffraction light from the first diffraction grating. A second reticle (11) is located at an image position of the lens and is formed with a second diffraction grating. A stage (12) moves the second reticle within a projection range of the lens (1). Interference fringes are formed on the second reticle by re-diffraction by the lens. Moire fringes are caused by the second diffraction grating and the interference fringes. The moire fringes are observed.



## **EUROPEAN SEARCH REPORT**

EP 90 30 9976

Category	Citation of document with in of relevant pa	ndication, where appropriate, ssages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)	
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